PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: 002187 USA/C03/PDC/WF/DB

(CA1120)

David ALUMOT, et al.

Allowed: January 24, 2005

Appln. No.: 09/765,995

Group Art Unit: 2623

Confirmation No.: 1810

Examiner: Mehrdad DASTOURI

Filed: January 19, 2001

For:

OPTICAL INSPECTION APPARATUS FOR SUBSTRATE DEFECT DETECTION (as

amended)

COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE

MAIL STOP ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants have the following brief comment concerning the Examiner's Statement of Reasons for Allowance. Instead of comparing the claims and the prior art, the Examiner provided a summary of the invention. To the extent that the Examiner's comments might be construed as limiting the scope of claims, Applicants respectfully disagree, and point to the

Atty. Docket No.: 002187 USA/C03/PDC/WF/DB (CA1120)
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language of the claims themselves as standing on their own as grounds for patentability.

Respectfully submitted,

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Date: March 9, 2005

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I hereby certify that this COMMENT ON STATEMENT OF REASONS FOR ALLOWANCE is being facsimile transmitted to the

CERTIFICATE OF FACSIMILE TRANSMISSION

U.S. Patent and Trademark Office this 9th day of March, 2005.

Mariano Tam